



Image 1764/\$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

January 23, 2004

Applicants: Bruce M. Warnes et al.

For : CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

Serial No.: 09/950 012

Group: 1764

Filed : Sept. 10, 2001

Examiner: Leung

Confirmation No. 9232

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PETITION FOR TIME EXTENSION

Sir:

A Response To Office Action is enclosed.

Pursuant to 37 CFR 1.136 (a), please extend the shortened period for response by one (1) month. The extension fee is:

☒ \$ 110.00 (37 CFR 1.17a1)

☐ \$ 55.00 (37 CFR 1.17a1; this application is entitled to small entity status)

A check for \$110.00 is enclosed for the time extension fee. The Commissioner is authorized to charge any additional extension or other fee that may be necessary to deposit account No. 20-1124.

Respectfully submitted,

IN DUPLICATE

Edward J. Timmer (Reg.No. 27 402)

Encl: listed above

CERTIFICATE OF MAILING

I hereby certify that this correspondence and enclosures are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 23, 2004.

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Edward J. Timmer